

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 4334

Junichiro YOSHIOKA et al.

Docket No. 2001 1740

Serial No. 09/990,387

Group Art Unit 1753

Filed November 23, 2001

SEMICONDUCTOR WAFER HOLDER AND ELECTROPLATING SYSTEM FOR PLATING A SEMICONDUCTOR WAFER

"SECOND" STATUS INQUIRY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This is a "second" Status Inquiry request. Please advise the undersigned Attorney of Record as to the present status of the above identified application, and advise when an Official Action may be expected.

Respectfully submitted,

Junichiro YOSHIOKA et al.

By:

Michael S. Huppert Registration No. 40,268 Attorney for Applicants

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